## THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7/A

application of:

John W. Svenkeson et al.

Group Art Unit:

1765

Serial No.:

Examiner:

Anita Karen Alanko

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METHOD OF FORMING ALIGNMENT

FEATURES FOR CONDUCTIVE DEVICES

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TC 1700

## AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents United States Patent and Trademark Office Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 4, 2002, please amend the above-identified application as follows:

## In The Claims

Please replace claim 11 as shown below. A marked up version of the amended claims is attached to this Amendment.

(Amended) The method of claim 9 wherein the ablating step comprises 11. ablating substrate material so as to form multiple apertures and multiple side edges, wherein the apertures and the side edges function as mechanical alignment features.

## CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Box, Commissioner for Patents, United States Patent and Trademark Office, Washington, D.C. 20231 on:

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